

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77911

Hideya TAKEO, et al.

Appln. No.: 10/684,708

Group Art Unit: 2624

Confirmation No.: 3651

Examiner: Sean T. MOTSINGER

Filed: October 15, 2003

For: ABNORMAL PATTERN CANDIDATE DETECTION PROCESSING METHOD AND  
SYSTEM

**STATEMENT UNDER 37 C.F.R. § 1.97(e)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: May 1, 2008

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